

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Naoto HORIGUCHI**

Serial Number: **Not Yet Assigned**

Filed: **February 2, 2004**

For: **SEMICONDUCTOR DEVICE AND METHOD OF FABRICATING THE SAME**

Attorney Docket No. **042073**

Customer No.: **38834**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

February 2, 2004

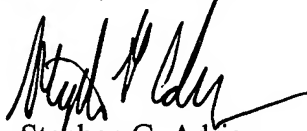
Sir:

In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,
WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP


Stephen G. Adrian
Reg. No. 32,878

1250 Connecticut Avenue, N.W., Suite 700
Washington, D.C. 20036
Tele: (202) 822-1100
Fax: (202) 822-1111
SGA/yap
Enclosures: PTO-1449; References (5)

INFORMATION DISCLOSURE STATEMENT PTO-1449	Attv. Docket No. 042073	Serial No. New Appln.
	Applicant(s): Naoto HORIGUCHI	
	Filing Date: February 2, 2004	Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____	AC		
_____	AD		
_____	AE		
_____	AF		

OTHER DOCUMENTS

_____	AG	Patent Abstracts of Japan, Publication No. 05267331, dated October 15, 1993.
_____	AH	Patent Abstracts of Japan, Publication No. 06224381, dated August 12, 1994.
_____	AI	Patent Abstracts of Japan, Publication No. 06338591, dated December 6, 1994.
_____	AJ	Patent Abstracts of Japan, Publication No. 11163157, dated June 18, 1999.
_____	AK	Patent Abstracts of Japan, Publication No. 2000196077, dated July 14, 2000.

Examiner	Date Considered
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